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Rib Data Shoot

## **CONFIRMATION NO. 1988**

| Bib Data Sheet  |  |   |                         |                      |   |                    |   |                            |
|---|--|---|-------------------------|----------------------|---|--------------------|---|----------------------------|
| SERIAL NUMBER<br>10/796,343   | FILING DATE<br>03/10/2004<br>RULE  | C | CLASS<br>438            | GROUP ART UN<br>2812 |   |                    | ATTORNEY<br>DOCKET NO.<br>08703.0005-01 |                            |
| APPLICANTS  |  |   |                         |                      |   |                    |   |                            |
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| ** CONTINUING DATA **********************************   |  |   |                         |                      |   |                    |   |                            |
| ** 05/24/2004 Foreign Priority claimed  yes and yes are sense and yes are |  |   |                         |                      |   |                    |   |                            |
| 35 USC 119 (a-d) conditions described and Acknowledged Examiner's Signafure Initials  |  |   | STATE OR COUNTRY TAIWAN |                      |   | TOT<br>CLAII<br>19 | MS                                      | INDEPENDENT<br>CLAIMS<br>3 |
| ADDRESS<br>22852<br>FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER<br>LLP<br>901 NEW YORK AVENUE, NW<br>WASHINGTON, DC<br>20001-4413  |  |   |                         |                      |   |                    |   |                            |
| TITLE<br>Method for reducing surface roughness of polysilicon films for liquid crystal displays   |  |   |                         |                      |   |                    |   |                            |
| No  | EES: Authority has been given in Paper o to charge/credit DEPOSIT ACCOUNT o for following: |   |                         |                      | All Fees  1.16 Fees (Filing)  1.17 Fees (Processing Ext. of time) |                    |   |                            |